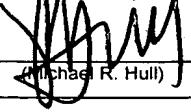


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I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: September 7, 2004 Signature: 

(Michael R. Hull)

Docket No.: 29936/39462
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Seung Cheol Lee

Application No.: 10/659,814

Art Unit: 2823

Filed: September 11, 2003

Examiner: Joannie A. Garcia

For: Method of Manufacturing Semiconductor Device

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Commissioner:

INTRODUCTORY COMMENTS

In response to the office action mailed on June 7, 2004, please amend the above-identified patent application as follows.

An amendment to the specification appears on page 2 of this paper.

Amendments to the claims and a complete listing of the claims begin on page 3 of this paper.

Remarks in support of the allowability of this application appear on page 5 of this paper.

A revised sheet 2 of drawings with a corrected Fig. 4 is attached hereto as an appendix.